

SAINTS@tlabs Course Framework

[S]outhern [A]frican [I]nstitute for [N]uclear [T]echnology and [S]ciences

Empowerment through education, training and practice

10 - 13 June 2024

Course Title: Introduction to Advanced Analytical Techniques (AAT)

Course Code: SC-AAT Lecturers/Facilitators:

[RB] Dr Remy Bucher, PhD (ETHZ), iThemba LABS NRF[ZK] Dr Zakhele Khumalo, PhD (UCT), iThemba LABS NRF

[MM] Prof. Malik Maaza, PhD (university of Paris), iThemba LABS NRF/UNISA

[MMa] Dr Morgan Madhuku, PhD (WITS), iThemba LABS NRF [NM] Dr Nametso Mongwaketsi, PhD (US), iThemba LABS NRF

[MMs] Prof. Mandla Msimanga, PhD (UCT), iThemba LABS NRF/ Tshwane Univ. of Technology

[CM] Dr Christopher Mtshali, PhD (UZ), iThemba LABS NRF
[MN] Dr Mlungisi Nkosi, PhD (UWC), iThemba LABS NRF
[PS] Dr Phillip Sechogela, PhD (UWC), iThemba LABS NRF
[NK] Dr Ntombizonke Kheswa PhD (UWC), iThemba LABS NRF
[LK] Dr Lebogang Kotsedi PhD (UWC), iThemba LABS NRF

[MAM] Dr Mamogo Masenya PhD (UWC), iThemba LABS NRF

Course Convener: Dr Mlungisi Nkosi (e-mail: m.nkosi@ilabs.nrf.ac.za)

Target group: Masters/doctoral students, junior research staff working on projects involving materials science.

No. of lectures: ~ 8 (1-hour duration each)

Practicals/demonstrations:

Course assessment method(s): research project, individual presentation etc.

Course certificate to be issued:

attendance (provided attendance > 90 %)

successful completion (provided attendance > 90 %, > 75 % ave. in assessment(s))

Presentation venue: virtual (Zoom platform) The Zoom link will be sent after registration. **Course dates/times: presentations [10 - 13 Jun 2024, 11h00 - 12h00 & 12h00 - 13h00]**

Course registration deadline: 08 June 2024

Course registration link: https://indico.tlabs.ac.za/event/133/registrations/104/

Contact for queries on course: Course Convener: m.nkosi@ilabs.nrf.ac.za

Contact for general queries: SAINTS Co-ordinator, e-mail address: saintsadmin@tlabs.ac.za





Course Outline

- Thin film deposition (sputtering vs e-beam) [NK] Monday (10 June @11am)
 - ➤ Introduction and basic principles of Thin film deposition
 - Physical Vapor Deposition Techniques
 - > Typical Applications
- Rutherford backscattering spectrometry (RBS) [PS] Monday (10 June @12pm)
 - ➤ Introduction and basic principle of (RBS)
 - Experimental setup and detection of scattered particles
 - o Normal and in-situ real-time RBS
 - > Resulting spectrum properties
 - > Typical application
- Elastic recoil detection analysis (ERDA) [MMs] Tuesday (11 June @11am)
 - Introduction and basic principle of ERDA
 - Experimental setup and detection of scattered particles
 - o Conventional ERDA and HI-ToF ERDA
 - Resulting spectrum properties
 - Typical application
- Particle induced x-ray emission (PIXE) [CM], [NM] Tuesday (11 June @12pm)
 - ➤ Introduction and basic principle of PIXE
 - Experimental setup and detection of scattered particles
 - Resulting spectrum properties
 - > Typical application
- Low Temperature Magnetism ([LK] Wednesday (12 June @11am)
 - Introduction and basic principle of VSM
 - > Experimental Set-up
 - > Typical applications
- Materials modification using charged particles [MMa], [MAM] Wednesday (12 June @12pm)
 - ➤ Introduction and basic principle of ion irradiation/implantation
 - Experimental setup
 - > Typical application
- Nuclear Sciences & Techniques in Nanosciences & Nanotechnologies [MM] Thursday (13 June @11am)
 - Introduction to nanosciences
 - Nanosystems by nuclear based radiations
 - ➤ Nanomaterials for neutron research reactors
- X-ray diffraction (XRD) [RB]- Thursday (13 June @12pm)
 - ➤ Introduction and basic principle of XRD
 - > Experimental setup and detection of x-rays particles
 - Resulting spectrum properties







